



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Karsten Schmidt et al. Art Unit : 2122
Serial No. : 10/672,288 Examiner : Unknown
Filed : September 26, 2003
Title : REMOTE DEBUGGING THROUGH FIREWALLS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

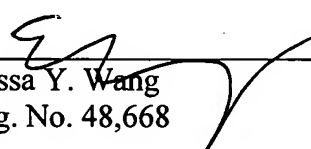
INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449. A copy of a communication from a foreign patent office in a counterpart application is also enclosed.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. A check for \$180 in payment of the late submission fee of §1.17(p) is enclosed. Please apply any other charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 2-26-04


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CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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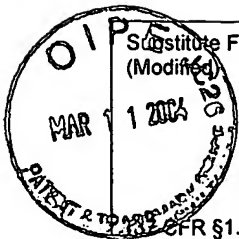
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 Substitute Form PTO-1449
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 U.S. Department of Commerce
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 Attorney's Docket No.
13913-053001

 Application No.
10/672,288

**Information Disclosure Statement
by Applicant**

(Use several sheets if necessary)

 Applicant
Karsten Schmidt et al.

 Filing Date
September 26, 2003

 Group Art Unit
2122

U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI	US2002/0129337	09/12/2002	Evans et al.			
	AJ	5,835,911	11/10/1998	Nakagawa et al.			
	AK	US2002/0066071	05/30/2002	Tien et al.			

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AL	EP 1 071 016 A2	01/24/2001	Europe				
	AM							
	AN							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AO	Richmond et al., "Reflections on Remote Reflection," IEEE (2001), pp. 163-170
	AP	
	AQ	
	AR	

Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.